

Search Notes 	Application/Control No.	Applicant(s)/Patent under Reexamination	
	09/920,138	LIU ET AL.	
	Examiner Tse Chen	Art Unit 2116	

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner
713	513	4/11/05	TSE
713	400	4/11/05	TSE